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| Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary) | Docket Number 356972020500 | Application Number 09/196,792 |
| | Applicant Seiichi NAKATANI et al. | |
| | Filing Date November 20, 1998 | Group Art Unit 2835 |

U.S. PATENT DOCUMENTS

| Examiner Initials | Ref. No. | Date | Document No. | Name | Class | Subclass | Filing Date If Appropriate |
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| Examiner Initials | Ref. No. | Date | Document No. | Country | Class | Subclass | Translation YES NO |
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